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Image 2823
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:)
OKU et al) Examiner: Dang, T.
Serial No.: 09/903,764) Art Unit: 2823
Filed: July 13, 2001)
For: FILM FORMING METHOD, SEMICONDUCTOR)
DEVICE AND SEMICONDUCTOR DEVICE)
MANUFACTURING METHOD)

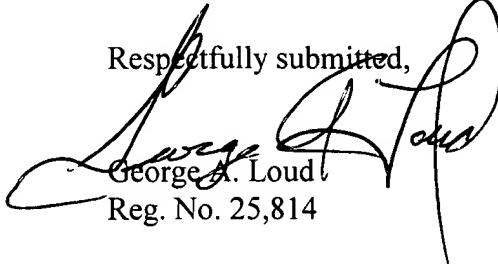
INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)(1)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the examiner consider and cite of record the three documents listed on the attached. Also submitted herewith is a copy of an office action issued by the Korean Patent Office on September 29, 2003 in connection with Korean Application No. 10-2001-004373 believed to correspond to the captioned application. This Korean office action cites as a reference Korean Patent Application 2002-9429. Also submitted herewith is a copy of EPO 1 174 916 believed to be an English language equivalent of the cited Korean document 2002-9429. Finally, also submitted herewith is a copy of European Application Publication No. 1174914 which is related to the aforementioned EPO publication. All of these publications are commonly owned by the assignee of the captioned application.

However, comparing their dates with the effective date of the present application, it does not appear that any of these documents are prior art against the captioned application.

Respectfully submitted,

George A. Loud
Reg. No. 25,814

Dated: October 29, 2003

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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.